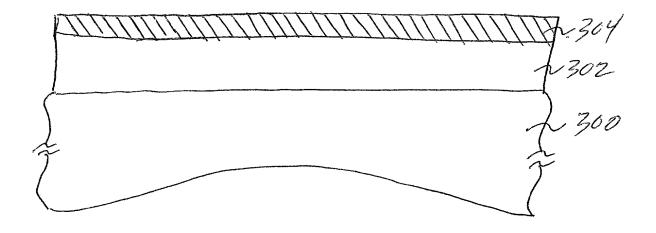


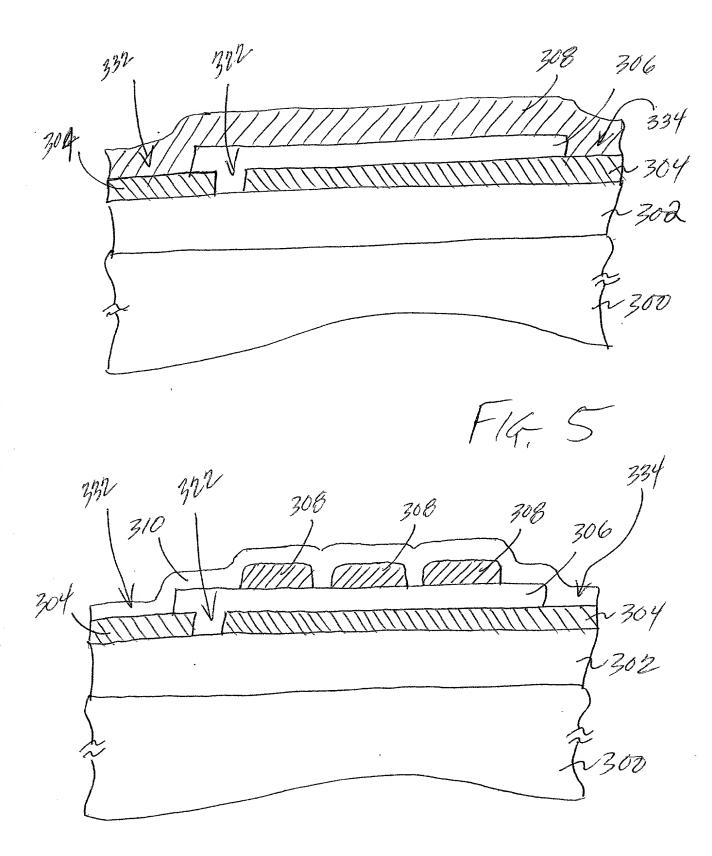
F.14. 1

FORM FIRST DIELECTRIC LAYER OVER SEMICONDUCTOR SUBSTRATE 202
V
FORM FIRST MAGNETIC LAYER OVER FIRST DIELECTRIC LAYER
V
PATTERN FIRST MAGNETIC LAYER TO DEFINE AT LEAST ONE SLOT
\bigvee
FORM SECOND DIELECTRIC LAYER OVER FIRST MAGNETIC LAYER, FILLING EACH SLOT IN FIRST MAGNETIC LAYER
PATTERN SECOND DIELECTRIC LAYER TO DEFINE AT LEAST ONE VIA TO FIRST MAGNETIC LAYER
FORM CONDUCTIVE LAYER OVER SECOND DIELECTRIC LAYER W212
PATTERN CONDUCTIVE LAYER TO FORM A CONDUCTOR HAVING A SPIRAL-SHAPED SIGNAL PATH AND TO CLEAR ANY VIAS TO FIRST MAGNETIC LAYER
FORM THIRD DIELECTRIC LAYER OVER CONDUCTIVE LAYER W 216
PATTERN THIRD DIELECTRIC LAYER TO DEFINE AT LEAST ONE VIA TO FIRST MAGNETIC LAYER
1
FORM SECOND MAGNETIC LAYER OVER THIRD DIELECTRIC LAYER, FILLING ANY VIAS TO FIRST MAGNETIC LAYER
PATTERN SECOND MAGNETIC LAYER TO FORM AT LEAST ONE SLOT



F14.4

and the same



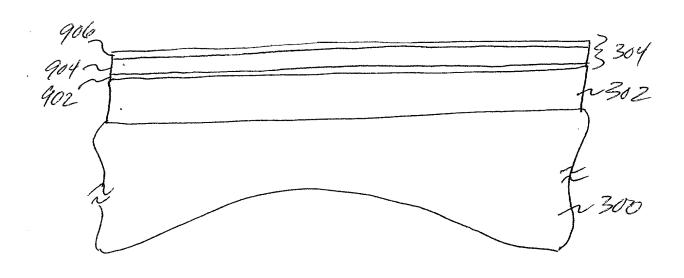
F14, 6

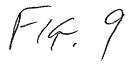
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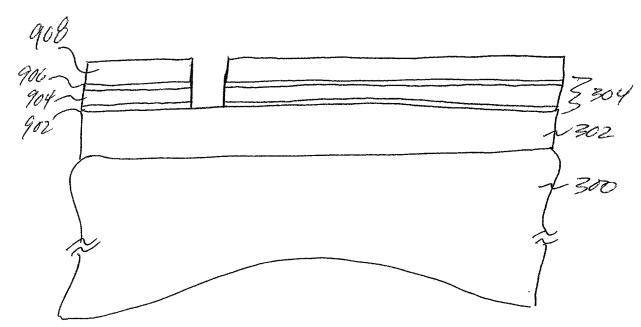
Maria.

900	
	FORM UNDERLYING LAYER OVER DIELECTRIC LAYER W802
	FORM MAGNETIC MATERIAL LAYER OVER UNDERLYING LAYER
	FORM OVERLYING LAYER OVER MAGNETIC MATERIAL LAYER SOLO
	FORM PATTERNED MASK LAYER OVER OVERLYING LAYER ~ 808

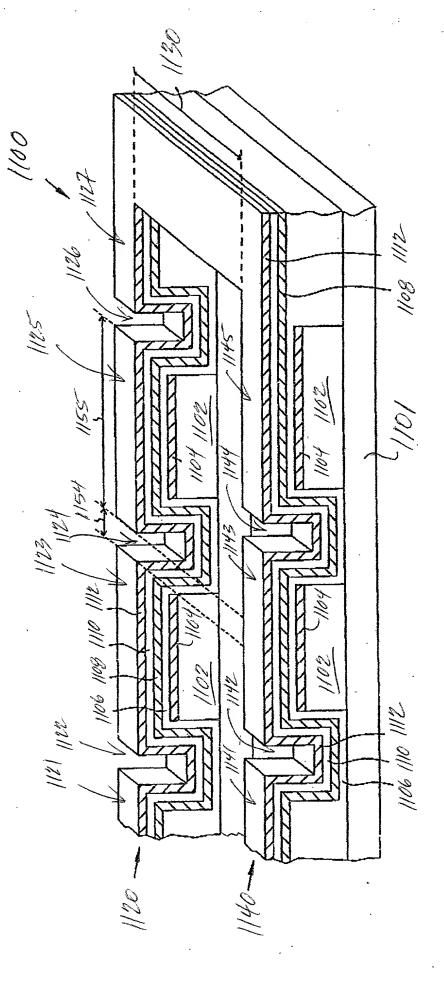
ETCH UNDERLYING, MAGNETIC MATERIAL, AND OVERLYING LAYERS







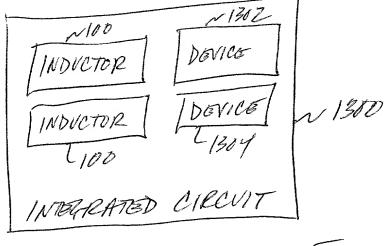
F14.10



1.4.

FO	RM FIRST DIELECTRIC LAYER OVER SEMICONDUCTOR SUBSTRATE
Ā	<u> </u>
	FORM FIRST MAGNETIC LAYER OVER FIRST DIELECTRIC LAYER / / 24
_	
_	
P	ATTERN FIRST MAGNETIC LAYER AND FIRST DIELECTRIC LAYER TO DEFINE PEDESTALS AND TRENCHES
	V
F	ORM SECOND DIELECTRIC LAYER OVER FIRST MAGNETIC LAYER AND IN TRENCHES
	1/
	PATTERN SECOND DIELECTRIC LAYER V/2/0
	FORM CONDUCTIVE LAYER OVER SECOND DIELECTRIC LAYER V/2/2
	.1/
	PATTERN CONDUCTIVE LAYER ~ /2/4
1	EODM THED DIELECTRIC LAYER OVER COMPLICATION A 1911
-	FORM THIRD DIELECTRIC LAYER OVER CONDUCTIVE LAYER 1/2/6
b	
	PATTERN THIRD DIELECTRIC LAYER 1216
	V /7
FC	ORM SECOND MAGNETIC LAYER OVER THIRD DIELECTRIC LAYER
	lininh
	PATTERN SECOND MAGNETIC LAYER 1222

F14,12



F14.13

INTEGRATED NIGOTOR INDUCTOR LIPOT LIPOT LIPOT LIPOT PACKAGE